



*C. Lawrence*  
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PATENT  
Atty. Docket No. SYP-060REC/N

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Vestal

SERIAL NUMBER: 09/755,951

ART UNIT: 1743

FILING DATE: January 4, 2001

EXAMINER: Soderquist, A.

TITLE: MASS SPECTROMETER SYSTEM AND METHOD FOR  
MATRIX-ASSISTED LASER DESORPTION  
MEASUREMENTS

Commissioner for Patents  
Washington, D.C. 20231

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AMENDMENT AND RESPONSE

Sir:

In response to the Office action mailed from the United States Patent and Trademark Office on July 17, 2001, ("the Office action") Applicant submits this Response. A petition and appropriate fee for a one month extension of time for response up to and including November 19, 2001, are submitted herewith.

AMENDMENT

In the Claims

Please amend claims 75 and 90 to read as follows (A marked-up version of the amended claims is attached at the end of this Amendment and Response).

75. (AMENDED) A system for obtaining mass data comprising:  
a mass spectrometer comprising an ion source chamber, wherein the ion source chamber  
comprises  
a sample receiving stage adapted to support a sample support, and

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02 FC:103  
03 FC:102

72.00 OP  
336.00 OP